



Form PTO-1449 (modified)

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INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

Atty. Docket No.
UTXC:569USC1Serial No.
09/902,933Applicant
Frederick F. Becker *et al.*Filing Date:
July 10, 2001Group:
1753U.S. Patent Documents
*See Page 1*Foreign Patent Documents
*See Page 1*Other Art
See Page 1

U.S. Patent Documents

| Exam. Init. | Ref. Des. | Document Number | Date | Name | Class | Sub Class | Filing Date of App. |
|-------------|-----------|-----------------|----------|--------------------|-------|-----------|---------------------|
| an | A51 | 5,582,701 | 12/10/96 | Geis <i>et al.</i> | 204 | 451 | 12/20/94 |

Foreign Patent Documents

| Exam. Init. | Ref. Des. | Document Number | Date | Country | Class | Sub Class | Translation Yes/No |
|-------------|-----------|-----------------|---------|---------|-------|-----------|--------------------|
| an | B10 | WO 97/20210 | 6/05/97 | WIPO | G01N | 33/187 | Abstract |

Other Art (Including Author, Title, Date Pertinent Pages, Etc.)

| Exam. Init. | Ref. Des. | Citation |
|-------------|-----------|---|
| an | C13 | Moesner and Higuchi, "Electrostatic devices for particle micro-handling," <i>Industry Applications Conference</i> , 13 th IAS Annual Meeting, Orlando, FL, October 8-12, 1995. |

25471937.1

EXAMINER:

Alb. Hagerola

DATE CONSIDERED:

01/21/2005

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